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Atty. Dkt. No. AMAT/2601.P11/PPC/ECP/RKK

OCT 15 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Mok, et al.

Group Art Unit: 1763

Serial No.: 09/785,815

Confirmation No.: 4127

Filed: February 16, 2001

Examiner: Sylvia MacArthur

For: INTEGRATED SEMICONDUCTOR
SUBSTRATE BEVEL CLEANING
APPARATUS AND METHODOK TO ENTER
AMENDMENTMAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450Robert Culbert
11/2/04CERTIFICATE OF FACSIMILE TRANSMISSION UNDER
37 CFR 1.8I hereby certify that this correspondence and the documents
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Dear Sir:

RESPONSE TO FINAL OFFICE ACTION DATED AUGUST 18, 2004

In response to the Final Office Action dated August 18, 2004, having a shortened statutory period for response set to expire on November 18, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/2601.P11/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 5 of this paper.

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